# Radiation hardness of small-pitch 3D pixel sensors up to HL-LHC fluences

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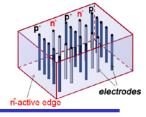
CNM-IMB-CSIC Barcelona

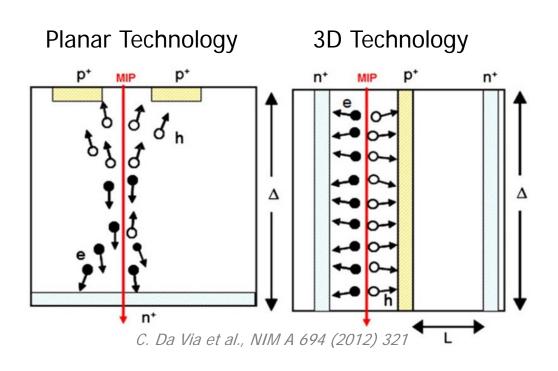
TIPP, Beijing, 24 May 2017





# **3D Detector Principle**





Radiation-hard and active/slim-edge technology

## Advantages

- Electrode distance decoupled from sensitive detector thickness
  - $\rightarrow$  lower  $V_{depletion}$ 
    - → less power dissipation, cooling
  - → smaller drift distance
    - → faster charge collection
    - → less trapping
- Active or slim edges are natural feature of 3D technology

## Challenges

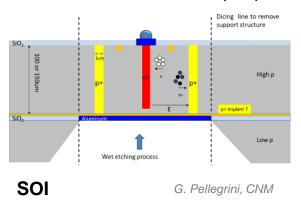
- Complex production process
  - → long production time
  - → lower yields
  - → higher costs
- Higher capacitance
  - → higher noise
- Non-uniform response from
  3D columns and low-field regions
  → small efficiency loss at 0°

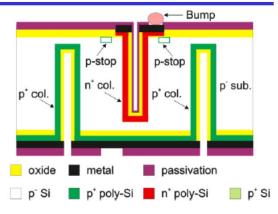


# **Different 3D Technologies**

#### Double sided (available at CNM)

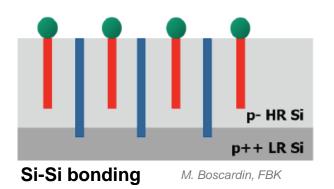
- IBL/AFP-proven technology
- No handling wafers needed
  → thickness limited to ≥200 µm and wafers to 4"
- 3D columns ~8 µm diameter
- Single sided (available at FBK, SINTEF, CNM)
  - On handling wafer (SOI or Si-Si bonding)
    → 6" possible (FBK, SINTEF)
  - Active thickness range 50-150 µm being explored
  - Narrow 3D columns ~5 µm possible





#### **Double-sided**

G. Pellegrini, CNM



# **Applications of 3D Silicon Pixel Detectors**



ATLAS IBL

See talk by D. Fares

- 25% 3D FEI4 detectors (CNM+FBK sensors)
- Running since June 2015
- ATLAS Forward Proton (AFP)

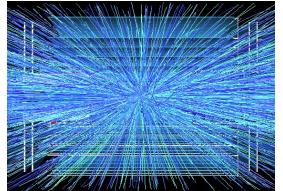
S. Grinstein et al., JINST 12 (2017) C01086

- CNM sensors, 3D pixel modules produced by IFAE
- Running in LHC since March 2016, upgraded in March 2017
- CMS-TOTEM PPS
  - CNM sensors
  - Installed in March 2017

### HL-LHC pixel detectors

This talk

- Possible installation 2024, sensor qualification for Pixel TDRs 2017
- Radiation hardness: 1-2e16 n<sub>eq</sub>/cm<sup>2</sup> required
- Reduced pixel size: 50x50 μm<sup>2</sup> or 25x100 μm<sup>2</sup>
- 3D promising candidate for innermost layer(s)

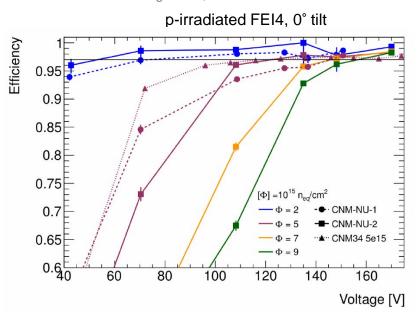


## State of the Art: IBL/AFP Generation

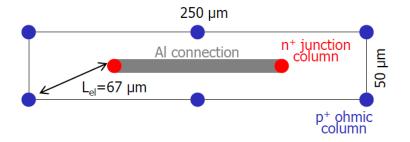
- 230 µm thick sensors by CNM and FBK (double-sided)
- FEI4s: 50x250 μm² 2E, 67 μm inter-el. distance
- Radiation hardness up to 5e15 n<sub>eq</sub>/cm<sup>2</sup> established (IBL)
- Explored limits further with irradiations up to HL-LHC fluences
  - At 9.4e15 n<sub>eq</sub>/cm<sup>2</sup>: 97.8% efficiency at 170 V!
  - Power dissipation 15 mW/cm<sup>2</sup> at 1e16 n<sub>eq</sub>/cm<sup>2</sup> and -25°C

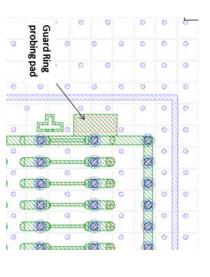
#### → Good performance at HL-LHC fluences even for existing 3D generation

J. Lange et al., 2016 JINST 11 C11024



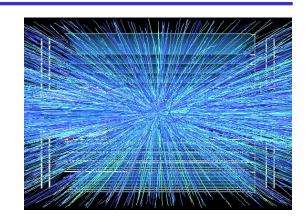
## Standard FE-I4 50x250 µm², 2E

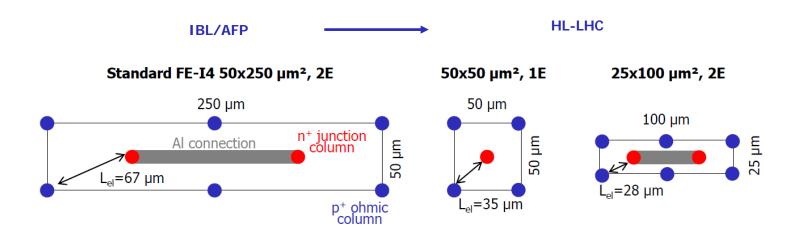




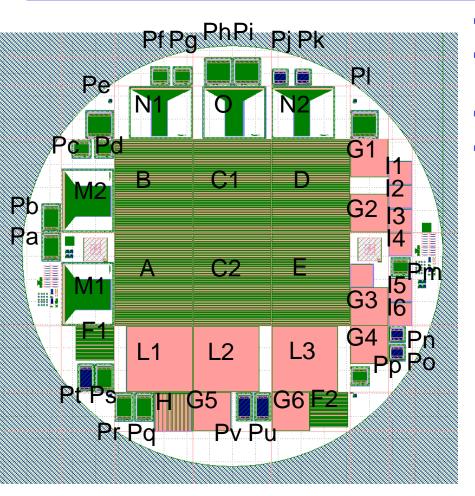
# **Development of HL-LHC 3D Pixel Detectors**

- Radiation hardness: 1-2e16 n<sub>eg</sub>/cm<sup>2</sup> required
- Reduced pixel size due to occupancy: 50x50 μm² or 25x100 μm²
  - RD53 readout chip under development
- Reduced 3D inter-electrode distance L<sub>el</sub>
  - → less trapping, V<sub>dep</sub>
  - → more radiation hard (but higher C<sub>det</sub> and more dead material)
- Possibly reduced thickness (75-150 µm single-sided)
  - Lower occupancy, I<sub>leak</sub>, C<sub>det</sub> (but also lower signal)
  - But here only 230 µm studied



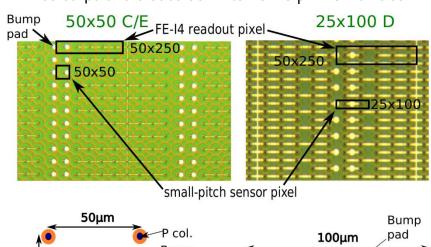


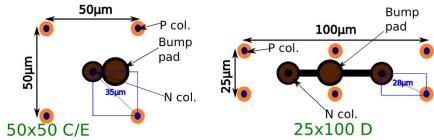
## First Small-Pixel CNM Run for HL-LHC



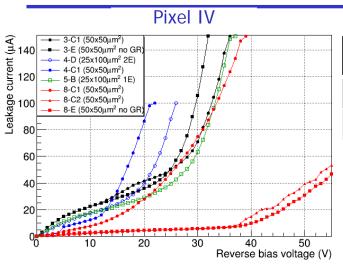
D. Vázquez Furelos et al., 2017 JINST 12 C01026J. Lange et al., 2016 JINST 11 C11024

- Run 7781 finished in Dec 2015
- 5x 4" wafers, p-type, 230 μm double-sided, nonfully-passing-through columns (a la IBL)
- Increased aspect ratio 26:1 (column diameter 8 μm)
- First time small pixel size 25x100+ 50x50 µm<sup>2</sup> (folded into FEI4 and FEI3 geometries)
  - Also strips and diodes down to 25x25 µm<sup>2</sup> 3D unit cell





# **Sample Characterisations**



Pixel Geom.	C/el. [fF] (*)	C/pixel [fF] (*)	Noise [e]
25x100 2E	42	84	160
50x50 1E	37	37	105-140

(\*) from pad diodes

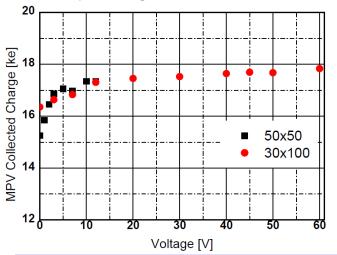
D. Vázquez Furelos et al., 2017 JINST 12 C01026

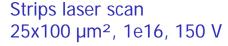
- Pixel devices bump-bonded and assembled at IFAE
- IVs
  - $V_{RD} \sim 15-40 \text{ V}$
  - Improved in new productions after
    CNM process optimization
    S. Grinstein et al., JINST 12 (2017) C01086
- C <100 fF/pixel (within RD53 limit)</li>
- Noise 100-160 e similar to standard 3D FEI4s
- Sr90 source scans on pixels
  - Similar charge as in standard FEI4s

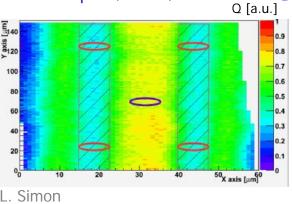
### Sr90 and laser scans on strips

- 17 ke charge as expected for both 50x50 µm<sup>2</sup> and 30x100 µm<sup>2</sup> (unirr.)
- Almost full charge even at 0-2 V
  → low V<sub>dep</sub> due to low L<sub>el</sub>
- Uniform even after 1e16 n<sub>ea</sub>/cm²
- Measurements up to 2e16 n<sub>eq</sub>/cm<sup>2</sup> in progress





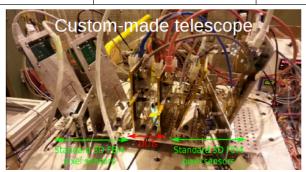




## **Beam Tests and Irradiations**

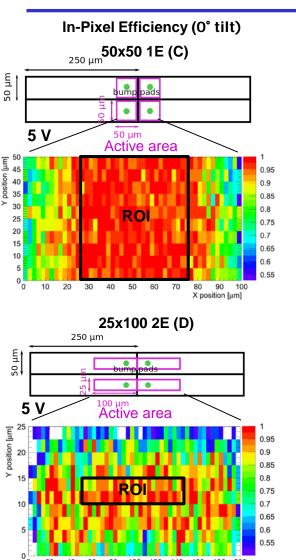
- Irradiation at KIT (uniform) and PS IRRAD (non-uniform)
- Beam tests at CERN SPS H6, 120 GeV pions

Beam Test period	Telescope	Reconstruction framework	Sensor geometry (µm²)	Irradiation (n <sub>eq</sub> /cm²)
May 2016	Custom-made 3D FEI4	Judith	50x50 + 25x100	Not irradiated
Nov 2016	EUDET	EUTelescope + TBmon2	50x50 + 50x50	5e15 (uniformly 23 MeV p+- KIT)
Sept 2016	EUDET	EUTelescope + TBmon2	50x50	1.4e16 (non uniformly 23 GeV p <sup>+</sup> - CERN PS)

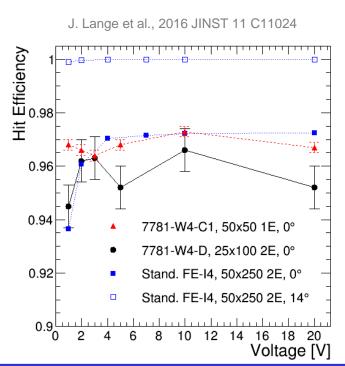


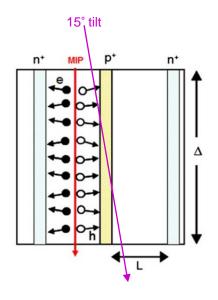


# **Efficiency before Irradiation**

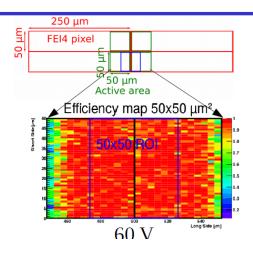


- Select ROI within active region
  → avoid inactive area + telescope smearing
- Efficiency in ROI
  - 97% already from 1 V at 0°: very early depleted due to small electrode distance
  - Improvable by tilting: avoids hitting only lowefficiency regions

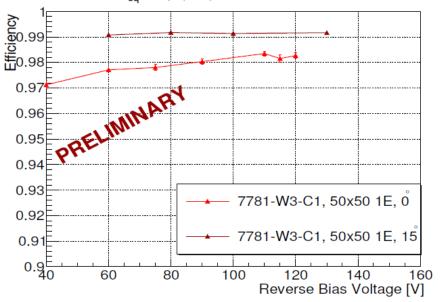




# Uniform Irradiation to 5e15 n<sub>eq</sub>/cm<sup>2</sup>

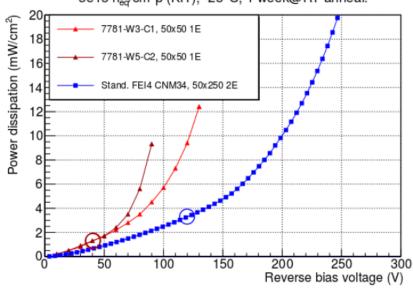


 $5e15 \, n_{ed}/cm^2 p$  (KIT), thr. 1 ke<sup>-</sup>, 10ToT@20ke

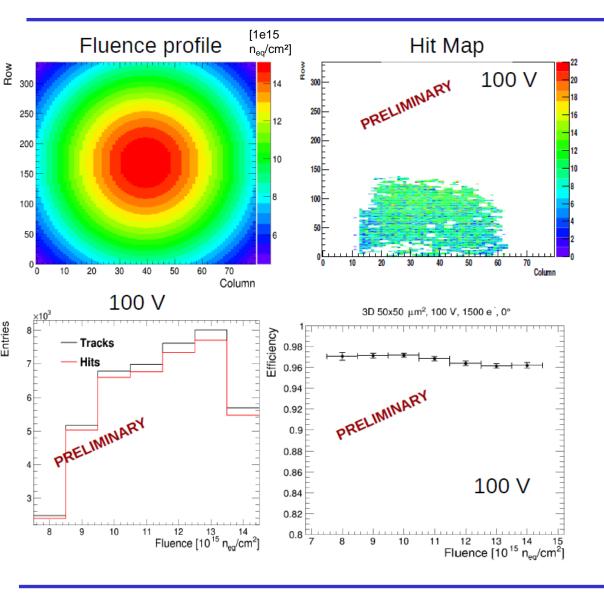


- 2 3D pixel devices of 50x50 μm²
- Irradiated uniformly to 5e15 n<sub>eg</sub>/cm<sup>2</sup> at KIT
- Already 97% efficiency at 40 V (0° tilt)!
  - Compare to standard IBL/AFP FEI4: 120 V
  - Improves to 99% at 15° tilt
- Low V<sub>op</sub> → advantage for power dissipation
  - 1.5 mW/cm²

5e15 n<sub>eg</sub>/cm<sup>2</sup>p (KIT), -25 °C, 1 week@RT anneal.

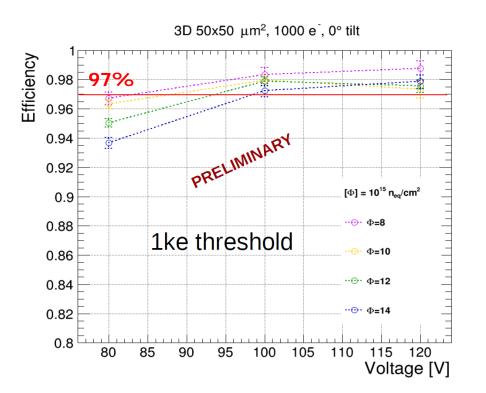


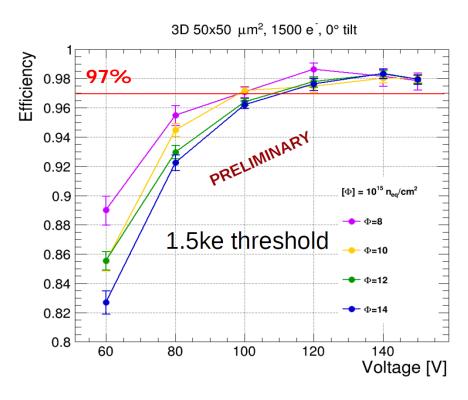
# Non-Uniform Irradiation to 1.4e16 n<sub>eq</sub>/cm<sup>2</sup>



- Non-uniform irradiation at CERN-PS (23 GeV p) with 20x20 mm<sup>2</sup> beam
  - Can sample range of fluences on single device: 0.8 – 1.4e16 n<sub>ea</sub>/cm²
  - Estimation of systematic fluence uncertainty from variations of beam width and position by 1 mm:
    - 11% at 1.4e16 n<sub>ea</sub>/cm<sup>2</sup>
    - 24% at 8e15 n<sub>eg</sub>/cm²
- Only part of device with connected bumps (bad UBM)
  - → Analysis in localised region

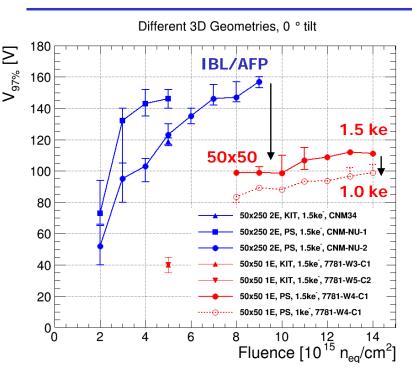
# **Efficiency for Non-Uniform Irradiation**





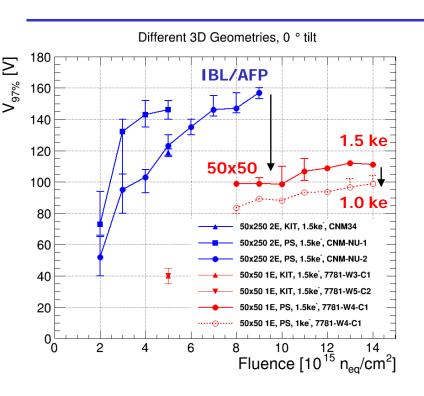
- Efficiency improves with lower threshold
- 97% efficiency already at 100 V (1 ke threshold) after 1.4e16 n<sub>eq</sub>/cm<sup>2</sup>!

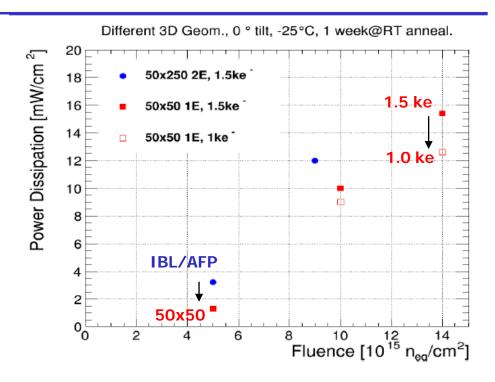
# **Comparison IBL to Small Pitch**



Highly improved operation voltage for 50x50 µm<sup>2</sup> 3D compared to IBL/AFP generation

# **Comparison IBL to Small Pitch**





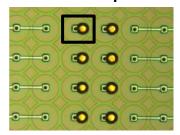
- Highly improved operation voltage for 50x50 µm<sup>2</sup> 3D compared to IBL/AFP generation
- Also improves power dissipation
  - Despite higher current for 50x50 μm² (still under investigation, might improve after optimisations)
  - 9 (13) mW/cm<sup>2</sup> at 1e16 (1.4e16) n<sub>eq</sub>/cm<sup>2</sup>
  - Considerably lower than for 100  $\mu$ m planar devices\* with ≥25 mW/cm² at 1e16  $n_{eq}$ /cm² ( $V_{op}$ =500 V)

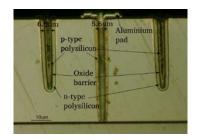
\* N. Savic et al., 28th RD50 Workshop, Torino, Italy, 6-8 June 2016

## **Conclusions and Outlook**

- Studied IBL/AFP-generation 3D pixel detectors up to HL-LHC fluences
  - Already excellent radiation hardness
- Studied first CNM 3D production with small HL-LHC pixel size
  - 50x50 and 25x100 µm² matched to FEI4 chip
  - Highly reduced operational voltage and power dissipation wrt.
    IBL/AFP generation (and planar) also after irradiation
    - 100 V for 1.4e16 n<sub>ea</sub>/cm<sup>2</sup>
  - Irradiation to higher fluences of 2-3e16 n<sub>eq</sub>/cm<sup>2</sup> on-going
- Also productions and promising results from FBK and SINTEF
  See talk by M. Meschini
- Single-sided thin (72-150 μm) 3D productions under way at CNM
  - Also with RD53 geometry







3D sensors excellent candidates for innermost pixel layer(s) at HL-LHC!

## **BACKUP**

